

December 3, 2001

BOX PATENT APPLICATION

Commissioner for Patents
Washington, D.C. 20231

Re: Application of Osamu NOZAWA
LITHOGRAPHY MASK BLANK AND METHOD OF MANUFACTURING THE SAME
Assignee: HOYA CORPORATION
Our Ref. Q67546

Dear Sir:

Attached hereto is the application identified above comprising twenty-five (25) sheets of the specification, including the claims and abstract, two (2) sheets of drawings, executed Assignment and PTO 1595 form, and executed Declaration and Power of Attorney. Also enclosed is an Information Disclosure Statement.

The Government filing fee is calculated as follows:

Total claims	6 - 20	=	x	\$18.00	=	\$0.00
Independent claims	1 - 3	=	x	\$84.00	=	\$0.00
Base Fee						\$740.00

TOTAL FILING FEE	\$740.00
Recordation of Assignment	\$40.00
TOTAL FEE	\$780.00

Checks for the statutory filing fee of \$740.00 and Assignment recordation fee of \$40.00 are attached. You are also directed and authorized to charge or credit any difference or overpayment to Deposit Account No. 19-4880. The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 and any petitions for extension of time under 37 C.F.R. § 1.136 which may be required during the entire pendency of the application to Deposit Account No. 19-4880. A duplicate copy of this transmittal letter is attached.

Priority is claimed from:

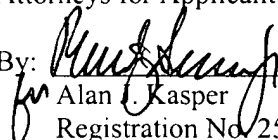
<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	367844/2000	December 1, 2000
Japan	329132/2001	October 26, 2001

The priority documents will be filed at a later date.

Since the anniversary of the priority date fell on a Saturday the filing of this application on Monday, December 03, 2001, is sufficient to obtain the benefit of priority.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

By:  # 21,092
for Alan J. Kasper
Registration No. 25,426